



05-10-02

wrong application

Attorney Docket SEL 144

2184
#9
3/4/03
Submission
B. M. M.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of)
)
Hiroki ADACHI)
437,699)
Serial No.: 09/441,026)
)
Filed: November 16, 1999)
)
For: Exposure Device,)
Exposure Method And Method)
of Manufacturing)
Semiconductor Device)
)
Art Unit: 2814)
)
Examiner: S. Rao)

"Express Mail" Mailing Label No. EL013564191US

Date of Deposit May 9, 2002

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to: Commissioner for Patents, Washington, D.C. 20231

Name Rachelle Pinnerquist
(typed or printed)

Signature Rachelle Pinnerquist

Commissioner for Patents
Washington, D.C. 20231

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PROOF OF PRIOR SUBMISSION

Sir:

On May 9, 2002, the Examiner assigned to this case called the undersigned regarding a response to the Restriction Requirement of October 1, 2001. In particular, the Examiner stated that he had not received a response to this Restriction Requirement. The undersigned checked his file and confirmed that an election was sent to the PTO on November 1, 2001 which is within the required time period. A copy of that election is enclosed herewith. This election had a certificate of mailing signed November 1, 2001. The undersigned has received a stamped post card from the PTO showing that the PTO did receive this election. A copy of the stamped post card is enclosed.

Therefore, Applicant has fully responding to the outstanding restriction requirement and requests examination of this application.


Please charge Deposit Account No. 50-1039 for any fee due for this submission.

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Favorable consideration is earnestly solicited.

Respectfully submitted,

Date: May 9, 2002


Mark J. Murphy
Registration No. 34,225

COOK, ALEX, McFARRON, MANZO,
CUMMINGS & MEHLER, LTD.
200 West Adams Street
Suite 2850
Chicago, Illinois 60606
(312) 236-8500

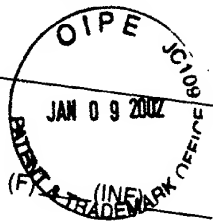


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- () Application _____
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- () Drawing Sheets no. _____ (F)
- () Transmittal Letter _____
- () Check \$ _____ No: _____
- () Declaration/Oath _____
- () Assignment and Cover Sheet _____
- () Information Disclosure Statement _____
- () Response/Amendment _____
- () Extension of Time (In Duplicate) _____
- () Small Entity Status _____
- () Copy of Priority Document _____
- (X) Election AND Amendment _____



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RE: APPLICATION

ATTY/SEC: MTM/plm
File no: SEL 144

Applicant: HIROKI Adachi

S.N.: 09/441,026 Filing Date: November 16, 1999

Title: Exposure Device, Exposure Method and Method of Manufacturing Semiconductor Device

Due date: November 1, 2001 Date Sent: November 1, 2001

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